



#19/4-21-03

NIT-215

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

S. KONDO et al

Serial No. 09/637,570

Group Art Unit: 2812

Filed: August 14, 2000

Examiner: Ha T. Nguyen

For: POLISHING METHOD, METALLIZATION FABRICATION
METHOD, METHOD FOR MANUFACTURING SEMICONDUCTOR
DEVICE AND SEMICONDUCTOR DEVICE

RECEIVED
APR 17 2003
TC 2800 MAIL ROOM

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
Washington, D.C. 20231


Sir:

It is respectfully requested that a second-month Extension of Time, to and including April 15, 2003, be granted in which to respond to the Office Action dated November 15, 2002 in the above-identified application. An Amendment and Petition for One Month Extension of Time were filed on March 17, 2003.

Our check including the amount of \$300.00 is attached in payment of the appropriate fee.

The Commissioner is hereby authorized to charge any additional payment due, or to credit any overpayment, to Deposit Account No. 50-1417.

Respectfully submitted,


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Date: March 17, 2003